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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1733
PATENT APPLICATION

IFW
AF
1733

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q68442

Tadahiro KEGASAWA, et al.

Appln. No.: 10/071,183

Group Art Unit: 1733

Confirmation No.: 2983

Examiner: Barbara J. MUSSER

Filed: February 11, 2002

For: RESIN FILM FORMING METHOD, AND LAMINATE PRODUCTION METHOD AND APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 17, 2004, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

| | |
|--------------------------------|---|
| AMENDMENTS TO THE CLAIMS | 2 |
| REMARKS | 6 |